



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Andreas et al.

**Serial No.:** 10/645,710

**Filed:** August 21, 2003

**For:** WAFER CLEANING METHOD AND  
RESULTING WAFER

**Confirmation No.:** 8457

**Examiner:** Tu Tu V. Ho

**Group Art Unit:** 2818

**Attorney Docket No.:** 2269-5663US  
(02-1325.00/US)

**Notice of Allowance Mailed:**

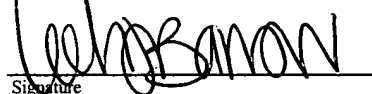
January 26, 2005

**CERTIFICATE OF MAILING**

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February 25, 2005

Date



Signature

Leah J. Barrow

Name (Type/Print)

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

**Amendments to the Specification** begin on page 3 of this paper.

**Serial No. 10/645,710**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 6 of this paper.

**Remarks** begin on page 12 of this paper.